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SERIAL NUMBER 10/739,202	FILING DATE 12/19/2003 RULE	CLASS 438	GROUP ART UNIT 2826	ATTORNEY DOCKET NO. 040021-0307298
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APPLICANTS

Geon-Ook Park, Seoul, KOREA, REPUBLIC OF;

** CONTINUING DATA ****

None EP

** FOREIGN APPLICATIONS ****

REPUBLIC OF KOREA 10-2002-0082001 12/20/2002

verified.

EP

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 03/29/2004

Foreign Priority claimed	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY	SHEETS	TOTAL	INDEPENDENT
35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	KOREA, REPUBLIC OF	DRAWING 3	CLAIMS 10	CLAIMS 2
Verified and Acknowledged	Examiner's Signature EP Initials				

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[see p. 7 of Examiner's Andt.]

TITLE

Formation method of gate electrode in semiconductor

a process

FILING FEE	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue)
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